

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Wayne G. RENKEN		
Title:	Process Condition Sensing Wafer and Data Analysis System		
Application No.:	10/685,550	Filing Date:	October 14, 2003
Examiner:	Hezron WILLIAMS	Group Art Unit:	2856
Docket No.:	SENS.005US1	Conf. No.:	4924

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**TRANSMITTAL OF RCE AND
REQUEST FOR EXTENSION OF TIME**

Sir:

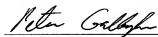
Transmitted herewith are the following documents in the above-identified application:

- (1) This Transmittal Letter;
- (2) Request for Continued Examination (RCE) Transmittal;
- (3) Amendment Accompanying RCE (for which no claims fee is due).

► Request is hereby made for a one-month extension of time to file these documents, up to and including **July 16, 2006**.

- ☒ The fees of \$395 (RCE) and \$60 (extension) have been authorized via EFS to Deposit Account 502664. The Commissioner is authorized to charge any additional fees or credit any overpayment to Deposit Account 502664.

Respectfully submitted,


Peter A. Gallagher
Reg. No. 47,584

July 16, 2006
Date